



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuyuki IRIE

Group Art Unit: 2851

Application No.: 10/628,363

Examiner: P. KIM

Filed: July 29, 2003

Docket No.: 109395.01

For: EXPOSURE METHOD AND EXPOSURE APPARATUS

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the February 16, 2005 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**